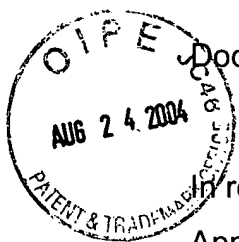


AF/2623
IFW

E0778



Docket No. AMDP440USA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re **PATENT** application of:

Applicant: Bryan K. Choo et al.

Application No.: 09/642,959

For: OPTIMIZATION OF OPC DESIGN FACTORS UTILIZING AN
ADVANCED ALGORITHM ON A LOW VOLTAGE CD-SEM
SYSTEM

Filing Date: August 21, 2000

Examiner: Ryan J. Hesseltine

Art Unit: 2623

REPLY TO THE ADVISORY ACTION DATED AUGUST 16, 2004

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Favorable reconsideration of the above-identified application is respectfully
requested in view of the following remarks.